

Notice of References Cited	Application/Control No. 10/810,795	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0040158 A1	02-2003	Saitoh, Takehiro	438/279
	B	US-2004/0104405	06-2004	Huang et al.	257/199
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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